

PIC configuration: Potential modification of skew quadrupoles (RQS)

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Powering and Beam Interlocks





Definition of essential and auxiliary

- Essential circuits are connected to unmaskable input of BIS
 => BEAM DUMP under any condition (including safe beams)
- Auxiliary circuits are connected to maskable input of BIS
 => BEAM DUMP if unsafe beams (can be masked on the BIS when running with safe beams)
 - NOTE: No difference between Essential and Auxiliary definition with unsafe beams!
- None of the above => no impact on beam



Present PIC configuration

- UNMASKABLE (essential for operation):
 - RB, RQD, RQF, RQX, RD1-4, RQ4-RQ10
- **MASKABLE** (not essential for operation):
 - RCS, RQT%, RSD%, RSF%, RQSX3, ROD, ROF, RCBXH/V and RCB%
- **NO IMPACT** (do not trigger the BIS)
 - RCD, RCO, **RQS.%**, RSS



Modifications during Run1

 RQSX3.%: Included in Maskable PIC configuration after trip provoking fast orbit changes and beam losses in SR7 (event on June 2011 – <u>ECR 1203408</u>)





Potential modification for 2017-TS1

- RQS.%: Propose to include in MASKABLE configuration to avoid dump on beam losses
 - Event on 16.06.2017: Trip of RQS.A81B1 provoked beam losses in R7.
 - Several families: RQS.A% (8 circuits), RQS.L/R% (8+8 circuits)
 - Currently studying the expected kicks from RQS circuits





How to deploy new configuration...

- Apply changes to reference DB
- Generate configuration data (script)
- Download new configuration to PLC
- Time estimated for changes: 4 hours
- Time estimated for validation: 2 hours
 - Run a few powering tests
 - Run PIC-BIC interface sequences





Thanks for your attention



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